



Nano and MEMS Sensors

Guest Editor:

Prof. Dr. Mustafa Yavuz

Mechanical and Mechatronics
Engineering Department,
University of Waterloo, Waterloo,
ON N2L 3G1, Canada

myavuz@uwaterloo.ca

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Message from the Guest Editor

Dear Colleagues,

The manufacturing and integration of autonomous and embedded sensors through a combination of micro- and nanosystem technologies have been revolutionizing self-powered, high bandwidth devices for advance manufacturing (AM), artificial intelligence (AI), and IoT.

More specifically, nano and MEMS sensors are the building blocks for a vast range of applications, from continuous real-time health (wearable) and environmental monitoring (gas, pressure, temperature, etc.) to enabling embedded mobile Internet services (wireless), including smart/connected cars and unattended vehicles (UAV) (inertial). As these devices have numbered in the tens of billions, the potential for disruptive innovation has been immense.

For further information, please visit mdpi.com/journal/sensors/special_issues/Nano_MEMS_Sensors.

Prof. Dr. Mustafa Yavuz
Guest Editor





Editor-in-Chiefs

Message from the Editorial Board

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